## **Refine Search**

## Search Results -

Terms	Documents
semiconductor and ((handle adj wafer) same TMAH)	13

US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
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Derwent World Patents Index
IBM Technical Disclosure Bulletins

Search:

L8		Refine Search
Recall Text	Clear	Interrupt

## **Search History**

DATE: Monday, January 24, 2005 Printable Copy Create Case

Set Name side by side		<u>Hit</u> <u>Count</u>	Set Name result set
DB=0	USPT; PLUR=YES; OP=ADJ		
<u>L8</u>	semiconductor and ((handle adj wafer) same TMAH)	13	<u>L8</u>
<u>L7</u>	semiconductor and (anodic adj bond\$) and ((handle adj wafer) same TMAH)	0	<u>L7</u>
<u>L6</u>	semiconductor and ((anodic adj bond\$) same (pressure or atmosphere)) and ((handle adj wafer) same TMAH)	0	<u>L6</u>
<u>L5</u>	semiconductor and ((anodic adj bond\$) same (pressure or atmosphere)) and (handle adj wafer)	11	<u>L5</u>
<u>L4</u>	semiconductor and ((anodic adj bond\$) same (pressure or atmosphere))	295	<u>L4</u>
<u>L3</u>	3922705.pn.	1	<u>L3</u>
<u>L2</u>	4079508	26	<u>L2</u>
<u>L1</u>	6077721	5	<u>L1</u>

**END OF SEARCH HISTORY**